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APPLICANTS

Toni D. Van Gompel, Austin, TX;

*SLG.*Mark D. Hall, Austin, TX;
Mohamad Jahanbani, Austin, TX; Michael D. Turner, San Antonio, TX;

** CONTINUING DATA *****

NONE *SLG*

** FOREIGN APPLICATIONS *****

NONE *SLG*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 03/24/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature	<i>SLG</i>	TX	6	25	4

ADDRESS

23125
 FREESCALE SEMICONDUCTOR, INC.
 LAW DEPARTMENT
 7700 WEST PARMER LANE MD:TX32/PL02
 AUSTIN , TX
 78729

TITLE

Method and apparatus for elimination of excessive field oxide recess for thin Si SOI

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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